



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q64059

Shigeo ISHIKAWA

/

Appln. No.: 09/832,093

/

Group Art Unit: 2823

Confirmation No.: 8684

Examiner: Khiem D. Nguyen

Filed: April 11, 2001

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For: FILM FORMING METHOD IN WHICH FLOW RATE IS SWITCHED

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP NON-FEE AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated February 13, 2003, please amend the above-identified application as follows:

RECEIVED

MAY 14 2003

TECHNOLOGY CENTER 2800

#11/B  
Ans  
J. Muller  
SP1/03